



Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 116916		APPLICATION NO. 10/644,989	
INFORMATION DISCLOSURE STATEMENT  (Use several sheets if necessary)				APPLICANT(S) Takamitsu HIGUCHI et al.			
				FILING DATE August 21, 2003		GROUP 2818	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
DV	A	Pignolet A., et al., "Large Area Pulsed Laser Deposition of Aurivillius-type Layered Perovskite Thin Films", Ferroelectrics, Overseas Publishers Associations, Amsterdam, NL, , Vol. 202, No. 1-4, 1997, pp. 285-298.					
DV	B	Mechin L. et al., "A combined x-ray specular reflectivity and spectroscopic ellipsometry study of CeO <sub>2</sub> /yttria-stabilized-zirconia bilayers on Si(100) substrates", Journal of Applied Physics, American Institute of Physics, New York, US, Vol. 84, No. 9, 1 November 1998, pp. 4935-4940.					
DV	C	Mathee T., et al., "Orientation relationships of epitaxial oxide buffer layers on silicon (100) for high-temperature superconducting Yba2Cu307-x films", Applied Physics Letters USA, Vol. 61, No. 10, 7 September 1992, pp. 1240-1242.					
EXAMINER <i>Finland</i>				DATE CONSIDERED <i>09/15/05</i>			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							

Date: February 11, 2005